國立交通大學電子物理系

碩士論文

光學掃瞄矽晶片背面之積體電路成像
Optical Scanning Technique Applied to the Backside Imaging of Silicon ICs

研究生: 龔俊穎

指導教授:謝太炯 教授

中華民國九十四年六月

光學掃瞄矽晶片背面之積體電路成像

Optical Scanning Technique Applied to the Backside Imaging of Silicon ICs

研究生 : 龔俊穎 Student : Jiun-Ying Gung

指導教授: 謝太炯 教授 Adivsor: Prof. Tai-Chiung Hsieh



A thesis
Submitted to Institute and Department of Electrophysics
College of Science
National Chiao-Tung University
in partial fulfillment of the Requirements
for the degree of
Master
In Electrophysics
June 2005
Hsinchu, Taiwan, Republic of China

中華民國九十四年六月